

Docket No.: 071971-0548

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Hideo NAKAGAWA, et al.	:	Confirmation Number: Not yet assigned
	:	
Application No.: Not Yet Assigned	:	Group Art Unit: Not Yet Assigned
	:	
Filed: May 03, 2006	:	Examiner: Not yet assigned
	:	
For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME		

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

A copy of the foreign search report is attached for the Examiner's information. Please note this is a PCT application in the entry of the National Phase in the U.S. and copies of the references cited were transmitted by WIPO and are believed to be in the file of the above identified application and readily available to the Examiner. Therefore it is

Not Yet Assigned

10/578003

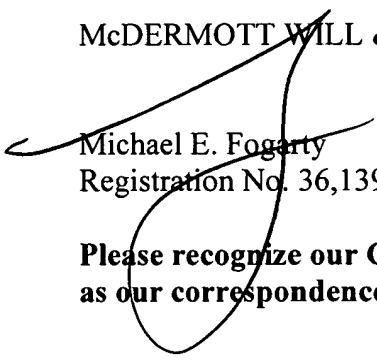
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believed that Applicants have met all requirements regarding duty of disclosure under 37 CFR 1.56. Acknowledgement and consideration of these documents are respectfully requested.

A copy of the foreign search report is attached for the Examiner's information. Please note this is a PCT application in the entry of the National Phase in the U.S. Since the Search Report was from the U.S. JPO or EPO search authorities, copies of these references should have been supplied to the USPTO under the trilateral agreement and are believed to be in the file of the above identified application and readily available to the Examiner.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP


Michael E. Fogarty
Registration No. 36,139

**Please recognize our Customer No. 20277
as our correspondence address.**

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 MEF:aph
Facsimile: 202.756.8087
Date: May 3, 2006

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 071971-0548		SERIAL NO. Not Yet Assigned 10/5/8003	
				APPLICANT Hideo NAKAGAWA, et al.			
				FILING DATE May 03, 2006		GROUP Not Yet Assigned	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US 2004/0038520 A1	2-26-2004	Seto, et al.			
		US 6,639,318	10-28-2003	Mitsui, et al.			
		US 6,720,659 B1	4-13-2004	Akahori			
		US 2002/0001944 A1	1-3-2002	Faust, et al.			
		US 6,747,353 B2	6-8-2004	Oizumi, et al.			
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes -Number -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No	
		JP 10-223755	8-21-1998	Hitachi Ltd		w/English Abstract	
		JP 2002-043419	2-8-2002	NEC Corp		w/English Abstract	
		JP 10-229084	8-25-1998	Nippon Telegr & Teleph Corp		w/English Abstract	
		JP 2002-075994	3-15-2002	Matsushita Electric Ind Co Ltd		w/English Abstract	
		JP 08-316233	11-29-1996	Toshiba Corp		w/English Abstract	
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		JP 2000-208443	7-28-2000	Sony Corp		w/English Abstract	
		JP 2003-297919	10-17-2003	Toshiba Corp			
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		JP 5-218035	8-27-1993	Sharp Corp			
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		JP 2002-353306	12-6-2002	Texas Instruments Inc.			
		JP 2002-231723	8-16-2002	Texas Instruments Inc.			
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.